



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re	Application of)	
Yamazaki et al.		I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:	
Serial No.: 10/642,803)	Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on
Filed: August 18, 2003)	9/8/08 (Date of Deposit)
For:	Semiconductor Device And Manufacturing Method Thereof)	Shannon Wallace Name of applicant, assignee, or Registered Rep.
Art Unit:)	Signature Date
Examiner:)	
	nissioner for Patents Box 1450		

PRELIMINARY AMENDMENT B

Sir:

Alexandria, VA 22313-1450

Prior to examination and calculation of fees, please amend the above-identified application as follows:

09/12/2003 BABRAHA1 00000018 10642803

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